

We claim:

Subt B'

1. A semiconductor structure for storing charges, comprising:
an insulator layer having a first compound that includes substances; and
a conductive layer having a second compound that includes a first substance
and a second substance, wherein the second compound in an as-deposited state
includes a substantial amount of the second substance so as to inhibit undesired
diffusion of at least one substance of the first compound from the insulator layer.

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2. The semiconductor structure of claim 1, wherein the first compound includes
ditantalum pentaoxide.

3. The semiconductor structure of claim 1, wherein the first substance includes
ruthenium atoms.

4. The semiconductor structure of claim 1, wherein the second substance
includes oxygen atoms.

5. The semiconductor structure of claim 1, wherein the second compound
includes RuO_x , wherein x is indicative of a desired number of atoms.

Subt B3

11. A semiconductor structure for storing charges, comprising:
an insulator layer having a permittivity value greater than about 25; and
a conductive layer having a compound, wherein the compound remains
stable when the insulator layer is crystallized at a high temperature so as to decrease
the charge leakage of the insulator layer.

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12. The semiconductor structure of claim 11, wherein the insulator layer
includes ditantalum pentaoxide.

13. The semiconductor structure of claim 11, wherein the compound includes
 RuO_x , wherein the x is indicative of a desired number of atoms.

14. The semiconductor structure of claim 11, wherein the high temperature
includes greater than about 750 degrees Celsius to less than about 801 degrees
Celsius.

15. The semiconductor structure of claim 11, wherein the conductive layer
passivates the insulator layer from undesired oxidation.

Subt B4

16. A semiconductor structure for storing charges, comprising:
an insulator layer having a permittivity value; and

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40. The method of claim 36, wherein forming the as-deposited film depositing the as-deposited film using a technique of chemical vapor deposition.
41. A method for enhancing a semiconductor structure that stores charges, comprising:
- forming a conductive layer of RuO_x ;
 - crystallizing to form RuO_2 and a trace amount of Ru;
 - forming an amorphous insulator layer of Ta_2O_5 ; and
 - crystallizing to form crystallized Ta_2O_5 , wherein the act of crystallizing to form crystallized Ta_2O_5 converts the trace amount of Ru into RuO_2 .
42. The method of claim 41, wherein crystallizing to form crystallized Ta_2O_5 includes crystallizing at a temperature of about 800 degrees Celsius.
43. The method of claim 41, wherein crystallizing to form crystallized Ta_2O_5 includes crystallizing in an ambient of dinitrogen oxide.
44. The method of claim 41, wherein crystallizing to form crystallized Ta_2O_5 includes crystallizing in an ambient of oxygen.

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50. ~~The method of claim 46, wherein forming a crystallized Ta₂O₅ includes forming at a temperature of about 800 degrees Celsius.~~

51. A memory device comprising:
an array of memory cells, wherein the array includes at least one capacitor that includes:
an insulator layer having a first compound that includes substances;
a conductive layer having a second compound that includes a first substance and a second substance, wherein the second compound in an as-deposited state includes a substantial amount of the second substance so as to inhibit undesired diffusion of at least one substance of the first compound from the insulator layer;
an address decoder;
a row access circuitry;
a column access circuitry;
a controller; and
an input/output circuit.

52. An electronic system comprising:
a plurality of circuit modules includes a plurality of dies, wherein at least one die includes at least one array of memory cells, wherein the array comprises at least one capacitor that includes:

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